

**INFORMATION DISCLOSURE STATEMENT**

Applicant : Tois et al.  
App. No : 10/678,766  
Filed : October 2, 2003  
For : METHOD OF GROWING OXIDE  
THIN FILMS  
Examiner : Matthew J. Song  
Art Unit : 1792  
Conf No. : 1629

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 21 references, of which 7 are submitted. Identification herein is not an admission that the cited references are prior art to the above-captioned application.

This Information Disclosure Statement is being filed before the mailing date of a final action and before the mailing of a Notice of Allowance. This Statement is accompanied by the fees set forth in 37 C.F.R. § 1.17(p). The Commissioner is hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. 11-1410.

Respectfully submitted,  
KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 12/17/09

By:   
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